

ABSTRACT OF THE DISCLOSURE

VACUUM LAMINATION SYSTEM AND VACUUM LAMINATION METHOD

A vacuum lamination system and a vacuum lamination method are provided, in which when a laminate film and laminate base items are laminated and then, an excessive portion of the laminate film is cut from the laminated item having the laminate film laminated thereon, a high precision lamination is enabled and the cutting process including a conveying device for cutting the excessive portion of the laminate film can be simplified. In the vacuum lamination system, a laminate film and laminate base items that are conveyed on the carrier film are laminated by the batch type vacuum laminating device, and the laminate film is cut from the laminated item having the laminate film laminated thereon. In a state in which the laminated item having the laminate film laminated thereon is mounted on the lower carrier film, the excessive portion of the laminate film is cut from the laminated item having the laminate film laminated thereon.

FIG. 1